

**Accountability Policy Advisory Committee (APAC)  
WBT Room 1-104**

**Agenda  
Tuesday, February 5, 2019  
9:00 a.m. to 5:00 p.m.**

|   |            |
|---|------------|
| <b>I. Welcome</b> .....   | 9:00–9:15  |
| <b>II. Goals for February APAC Meeting</b> .....                                      | 9:15–9:30  |
| <b>III. 2019 and Beyond Accountability Development</b> .....                          | 9:30–12:00 |
| • AEA and Dropout Recovery School Options   |            |
| ○ Prior-Year Non-Proficient Testers   |            |
| ○ Growth in CCMR  |            |
| ○ Bonus Points (Excluded Students Credit and Graduation Plans)                        |            |
| ○ Other Suggested Options   |            |
| • AEA Registration Criteria   |            |
| <b>Lunch</b> .....  | 12:00–1:00 |
| <b>IV. 2019 and Beyond Accountability Development</b> .....                           | 1:00–5:00  |
| • Step 10 (3 of 4 <i>F</i> s= <i>F</i> Overall) Outcomes                              |            |
| • Comprehensive, Targeted, and Additional Targeted Identification and Exit Criteria   |            |
| ○ Clarifying Points   |            |
| ○ Minimum Size Criteria   |            |
| • Closing the Gaps Domain   |            |
| ○ 6-Year Graduation Rate for 67% Graduation Rate Comprehensive Support Identification |            |

The Accountability Policy Advisory Committee (APAC) develops and makes recommendations to the commissioner of education regarding technical matters related to the state academic accountability system. The committee neither controls nor supervises public business or policy. To ensure that the recommendations are thoughtful and carefully considered, Texas Education Agency (TEA) staff establishes a forum in which committee members feel comfortable to freely express thoughts and feelings and relate experiences.

For this reason, and in accordance with the Attorney General's *Open Meetings Handbook 2018*, the meetings of APAC are closed to the public. Only committee members and relevant TEA staff may attend.